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Title of Invention	Method of Managing Wafer Defects
First Named Applicant :	Hung-En Tai
Attorney Docket Number :	LKSP0051USA
I hereby appoint the registered practitioner(s) at Customer Number: 027765 	
as attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.	
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